

 Sughrue

SUGHRUE MION, PLLC

January 28, 2004

MAIL STOP PATENT APPLICATION

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Re: Application of Yoshihiko UCHIDA and Kenji NAKAMURA
ORGANIC SEMICONDUCTOR ELEMENT AND FABRICATION METHOD
THEREOF

Assignee: **PIONEER CORPORATION**

Our Ref. Q79569

Dear Sir:

Attached hereto is the application identified above comprising sixteen (16) sheets of the specification, including the claims and abstract and three (3) sheets of drawings. **The requisite U.S. Government Filing Fee, copies of the executed Declaration and Power of Attorney and Assignment will be submitted at a later date.**

The Government filing fee is calculated as follows:

Total claims	<u>14</u>	-	<u>20</u>	=	<u> </u>	x	\$18.00	=	<u> </u>	\$0.00
Independent claims	<u>2</u>	-	<u>3</u>	=	<u> </u>	x	\$86.00	=	<u> </u>	\$0.00
Base Fee										\$770.00

TOTAL FEE

\$770.00

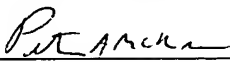
Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2003-19995	January 29, 2003

The priority document is submitted herewith.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

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